

# Unveiling the Structural and Electrochemical Effects of Al<sub>2</sub>O<sub>3</sub> Incorporation within LiPON Electrolyte Thin Films by Atomic Layer Deposition

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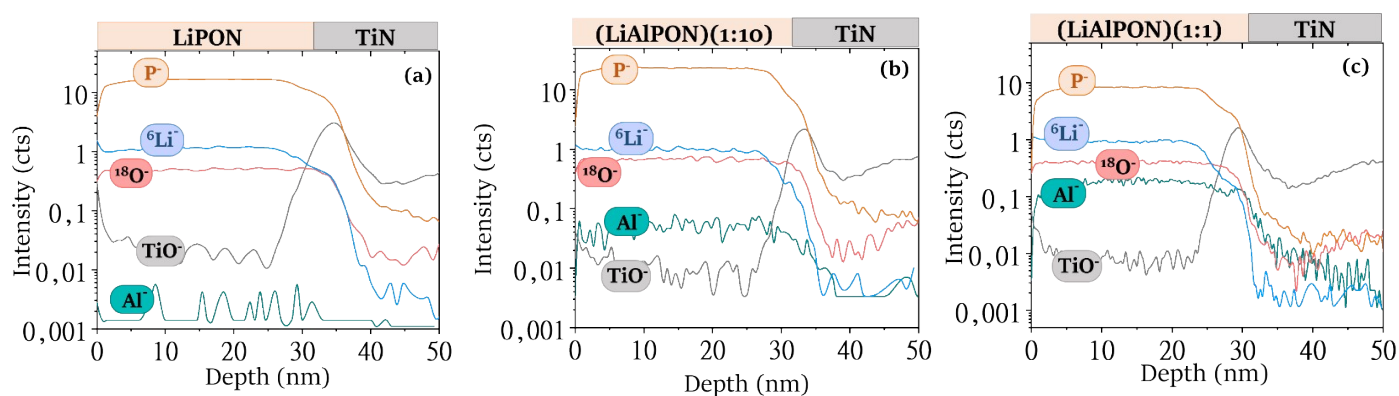
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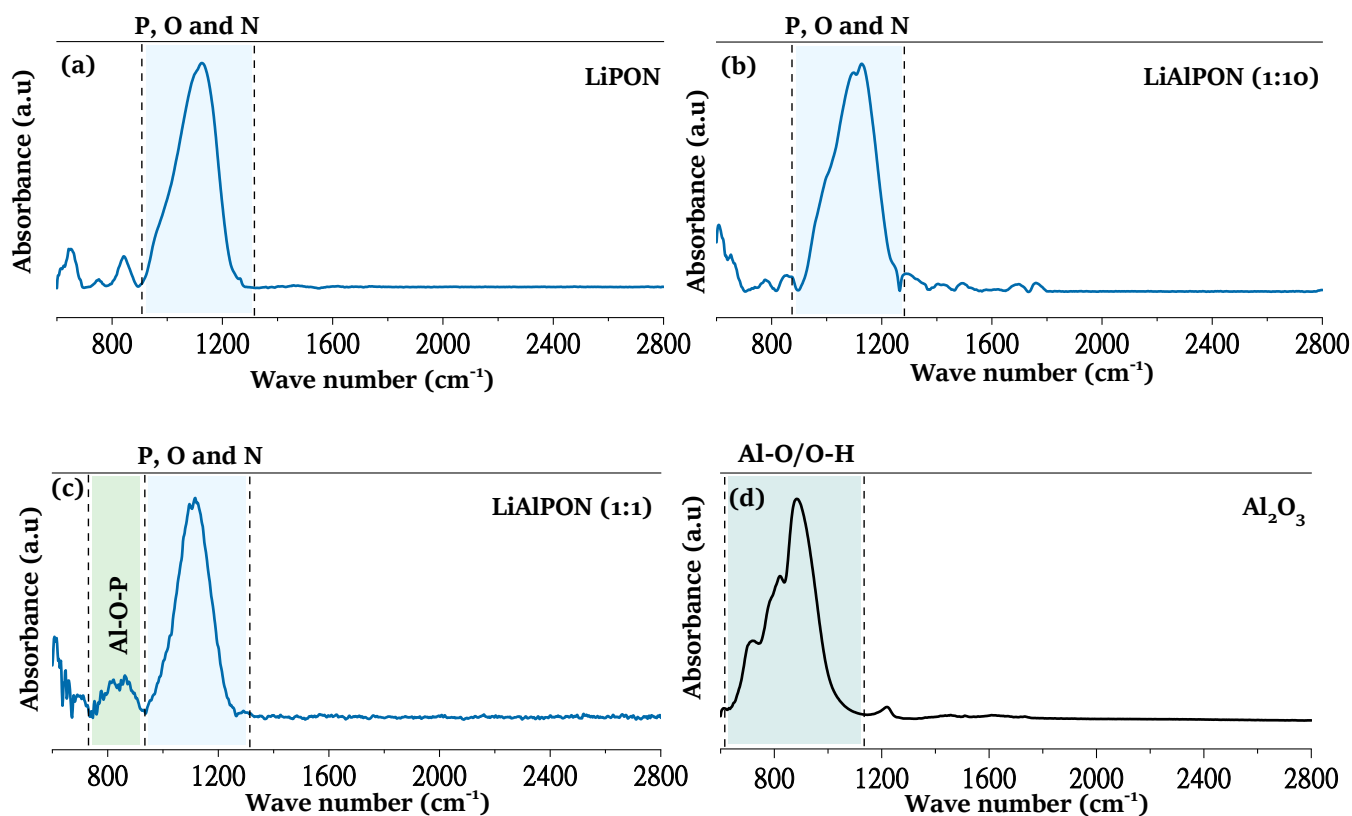
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## Supporting Information

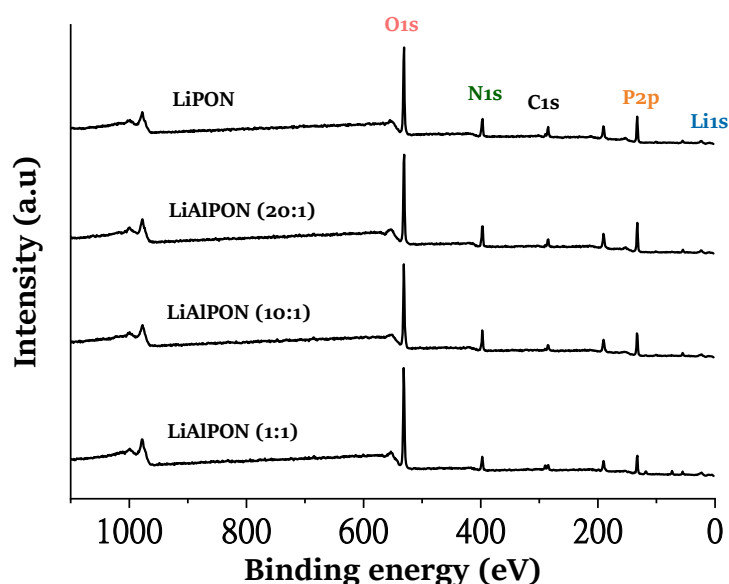


**Figure S1.** Survey depth profiles as measured with ToF-SIMS of (a) LiPON, (b) LiAlPON<sub>(10:1)</sub> and (c) LiAlPON<sub>(1:1)</sub> doped film



**Figure S2.** Full FTIR spectra of LiPON films as a function of  $\text{Al}_2\text{O}_3$  incorporation: (a) LiPON, (b) LiAlPON(10:1) (c) LiAlPON(1:1) (d)  $\text{Al}_2\text{O}_3$ .

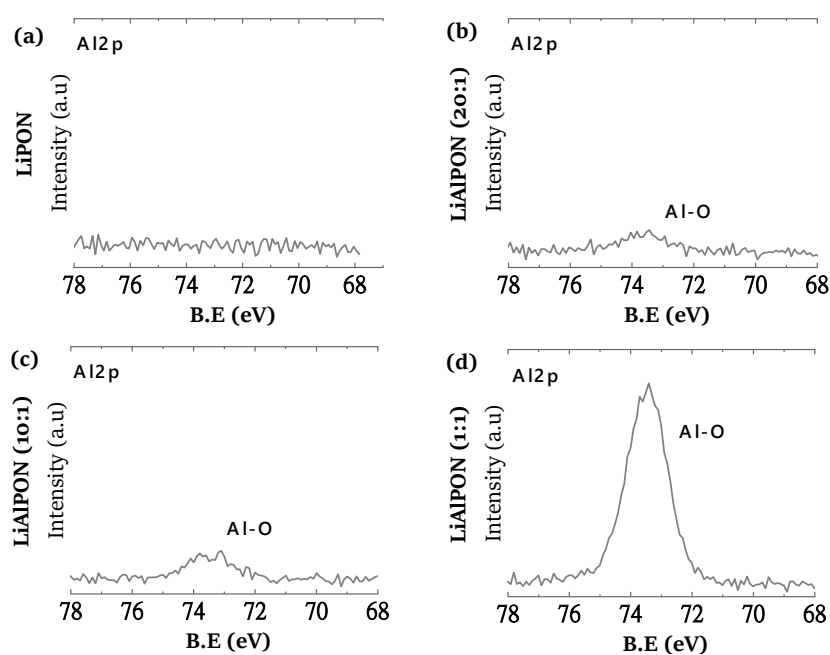
The 30 nm thin films were deposited on Si substrates and recorded in the 600–2800  $\text{cm}^{-1}$  range. For LiPON-based films, the main FTIR peaks appear between 850 and 1250  $\text{cm}^{-1}$ , corresponding to phosphate units. In contrast, the spectrum of the pure  $\text{Al}_2\text{O}_3$  film shows a major peak shifted to 700–1000  $\text{cm}^{-1}$ , primarily arising from Al–O and Al–O–Al bindings. The evolution of these spectral features highlights the structural effect of  $\text{Al}_2\text{O}_3$  incorporation. For clarity, peak deconvolution was performed using OriginLab with Gaussian fitting [1].



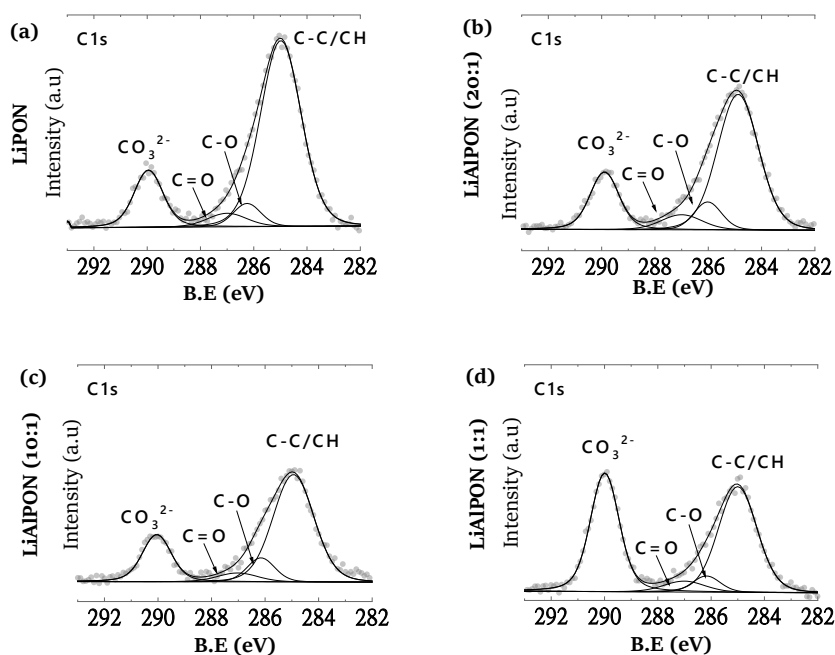
**Figure S3.** XPS survey spectra of pristine and Al-doped LiPON thin films. The films were deposited on SiO<sub>2</sub> substrates with a thickness of 30 nm. Despite the relatively low energy resolution of the survey spectra, all elements characteristic of LiPON-based films (Li 1s, O 1s, P 2p, N 1s, and C 1s) were clearly detected under different doping conditions and high-resolution scans are used to identify specific functional groups in the article manuscript.

**Table S1.** Summary of the binding energies and atomic concentrations (at. %) of the different chemical environments identified from the XPS spectra.

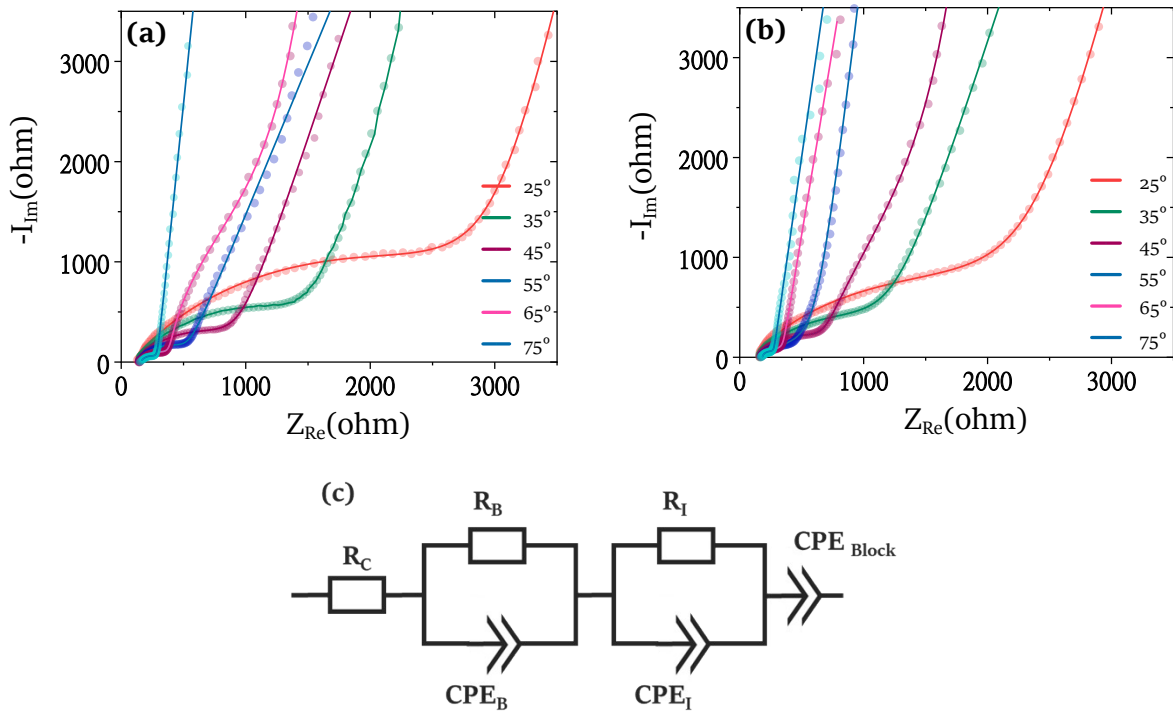
| Sample Identifier |                               | LiPON    |      | LiAlPON (20 : 1) |      | LiAlPON (10 : 1) |      | LiAlPON (1 : 1) |      |
|-------------------|-------------------------------|----------|------|------------------|------|------------------|------|-----------------|------|
|                   | Environment                   | Position | %    | Position         | %    | Position         | %    | Position        | %    |
| O 1s              | Li+...O-P                     | 531.3    | 22.8 | 531.1            | 26.4 | 531.2            | 26,8 | 531.3           | 24.1 |
| O 1s              | P-O-P                         | 532.4    | 3.5  | 532.4            | 2.6  | 532.4            | 3,2  | 532.4           | 3.6  |
| O 1s              | P=O                           | 530.9    | 8.0  | 530.7            | 5.5  | 530.7            | 2,2  | 530.8           | 11.7 |
| O 1s              | Li <sub>2</sub> O             | --       | --   | --               | --   | 528.6            | 2,6  | 528.5           | 1.1  |
| N 1s              | N divalent                    | 397.1    | 8.9  | 397.0            | 9.6  | 397.1            | 9,8  | 397.1           | 5.0  |
| N 1s              | N trivalent                   | 398.8    | 4.1  | 398.7            | 3.3  | 398.8            | 2,2  | 398.9           | 2.7  |
| C 1s              | C-C / C-H                     | 284.9    | 8.8  | 284.8            | 6.1  | 284.9            | 5.3  | 285.0           | 3,9  |
| C 1s              | C-O                           | 286.2    | 0.7  | 286.0            | 0.8  | 286.1            | 0.8  | 286.1           | 0,4  |
| C 1s              | C=O                           | 287.0    | 0.6  | 287.0            | 0.6  | 287.0            | 0.4  | 287.0           | 0,4  |
| C1s               | CO <sub>3</sub> <sup>2-</sup> | 289.9    | 2.0  | 289.8            | 1.9  | 290.0            | 1.7  | 289.9           | 3,5  |
| Li 1s             | LiPON / Li <sub>2</sub> O     | 55.3     | 27.1 | 55.2             | 28.9 | 55.3             | 31.3 | 55.3            | 24,0 |
| P 2p              | P2p <sub>3/2</sub>            | 132.7    | 8.1  | 132.6            | 8.3  | 132.7            | 7.7  | 132.7           | 5,0  |
| P 2p              | P2p <sub>1/2</sub>            | 133.6    | 4.0  | 133.5            | 4.2  | 133.6            | 3.8  | 133.6           | 2,5  |
| Al 2p             | Al-O                          | --       | --   | 73.6             | 0.3  | 73.4             | 0.6  | 73.4            | 2,6  |



**Figure S4.** High-resolution Al2p spectra for (a) LiPON, (b) LiAlPON(20:1) (c) LiAlPON(10:1) (d) LiAlPON(1:1).

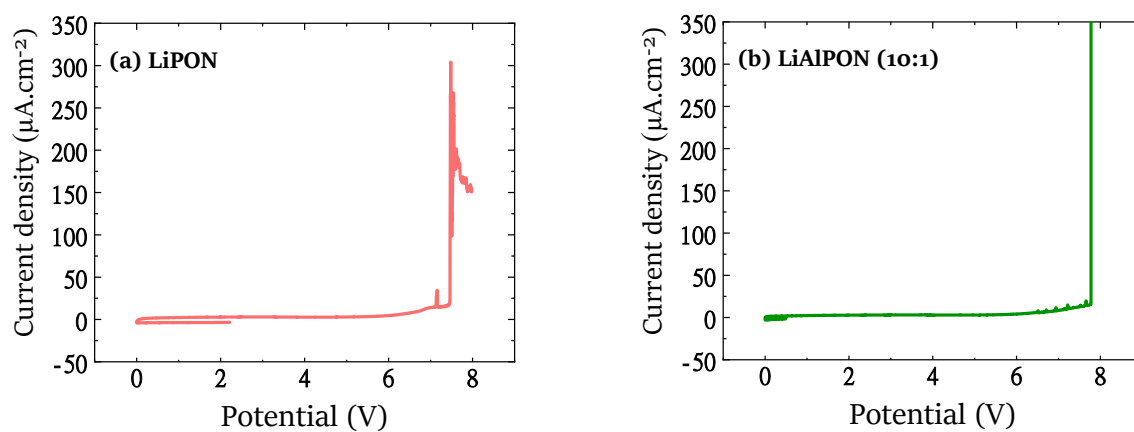


**Figure S5.** High-resolution C 1s spectra for (a) LiPON, (b) LiAlPON(20:1) (c) LiAlPON(10:1) (d) LiAlPON(1:1). All films exhibit the C–C/C–H hydrocarbon peak at 285 eV. For clarity, a key is provided for each contribution, including C–O, C=O, and  $\text{CO}_3^{2-}$  groups, observed at 286, 287.5, and 290 eV, respectively [2], [3].



Ionic conductivity was extracted by fitting an equivalent circuit model to the impedance spectroscopy response. The equivalent circuit includes a single contact ohmic resistance,  $R_C$ , which corresponds to the high-frequency limiting resistance of the electrode [4]. Ionic conduction processes are modelled using two parallel resistor/constant phase element (CPE) pairs. The first pair,  $R_B$  and  $CPE_B$ , corresponds to the bulk of the LiPON electrolyte, while the second pair,  $R_I$  and  $CPE_I$ , represents the resistive layer between Lipon and deposited Pt electrodes. Finally, a single  $CPE_{dl}$ , accounts for the formation of the electrochemical double layer at low frequency [5], [6].

**Figure S6.** Nyquist plots for progressive temperatures ranging from 25 °C to 75 °C for (a) LiPON and (b) LiAlPON (10:1) (c) Equivalent circuit for Nyquist spectra fitting



**Figure S7.** Cyclic voltammograms of **(a)** LiPON and **(b)** LiAlPON<sub>(10:1)</sub> doped thin films in the voltage range of 0 - 8 V at the scan rate of 100 mV.s<sup>-1</sup>

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